



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Gary M. Moore
Assignee: Moore Epitaxial Inc.
Title: METHOD OF CONTROLLING GAS FLOW TO A SEMICONDUCTOR
PROCESSING REACTOR
Serial No.: 09/765,919 Filed: January 18, 2001
Examiner: Chen, Bret P. Group Art Unit: 1762
Docket No.: MTEC101001

Monterey, CA
November 6, 2002

Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Dear Sir:

In response to the Office Action dated August 6, 2002,
enclosed herewith are:

1. A separate paper entitled "Clean Copy of
Description Replacement Paragraphs" with a clean version
of each replacement paragraph in the specification along
with a clear instruction for entry (3 pages); and
2. A separate paper entitled "Version with Markings
to Show Changes Made" with markings to show amendments to
the specification (4 pages).

The above papers are incorporated herein by reference in their
entireties as a part of this paper.

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